

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. Serial No. : 09/967,081
Applicant(s) : Hong Hie Lee, et al.
Filed : September 28, 2001
Entitled : METHOD FOR FORMING A MICRO-PATTERN ON A
SUBSTRATE BY USING CAPILLARY FORCE
Examiner : Culbert, Roberts P. ART UNIT : 1763

Mail Stop NON FEE AMENDMENT
Commissioner for Patents
P. O. Box 1450
Alexandria VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action of November 6, 2003, please amend
the above-identified application as follows:

Amendments the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which
begins on page 3 of this paper.

Remarks/Arguments begin on page 8 of this paper.

